



09-04-01



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Kei-Yu Ko

Title: NITRIDE SELECTIVE AND FIELD OXIDE SELECTIVE SEMICONDUCTOR ETCHING

Attorney Docket No.: 303.696US1

PATENT APPLICATION TRANSMITTAL

BOX PATENT APPLICATION

Commissioner for Patents

Washington, D.C. 20231

We are transmitting herewith the following attached items and information (as indicated with an "X"):

- ☒ Return postcard.
- ☒ Utility Patent Application under 37 CFR § 1.53(b) comprising:
 - ☒ Specification (22 pgs, including claims numbered 1 through 64 and a 1 page Abstract).
 - ☒ Formal Drawing(s) (7 sheets).
 - ☒ **Signed Declaration** (3 pgs).
 - ☒ Signed Power of Attorney (1 pg.)
 - ☒ Check in the amount of \$2,062.00 to pay the filing fee.
- ☒ Assignment of the invention to Micron Technology, Inc. (2 pgs) and Recordation Form Cover Sheet.
- ☒ ~~Check in the amount of \$40.00 to pay the Assignment recording fee.~~

The filing fee has been calculated below as follows:

	No. Filed	No. Extra	Rate	Fee
TOTAL CLAIMS	64 - 20 =	44	x 18 =	\$792.00
INDEPENDENT CLAIMS	10 - 3 =	7	x 80 =	\$560.00
MULTIPLE DEPENDENT CLAIMS PRESENTED				\$0.00
BASIC FEE				\$710.00
TOTAL				\$2,062.00

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This paper or fee is being deposited on the date indicated above with the United States Postal Service pursuant to 37 CFR 1.10, and is addressed to The Commissioner for Patents, Box Patent Application, Washington, D.C. 20231.